

Docket No.: HSI-0001



PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

Confirmation No.: **1151**

**Sang Dae KIM et al.**

Group Art Unit: **1763**

Serial No.: **10/621,471**

Examiner: **Richard R. BUEKER**

Filed: **July 18, 2003**

Customer No.: **34610**

For: **SOURCE FOR THERMAL PHYSICAL VAPOR DEPOSITION OF ORGANIC ELECTROLUMINESCENT LAYERS**

**AMENDMENT**

U.S. Patent and Trademark Office  
Customer Window, Mail Stop Amendment  
Randolph Building  
401 Dulany Street  
Alexandria, Virginia 22314

Sir:

In reply to the Office Action dated July 27, 2005, please amend the above-identified application as follows:

**Amendments to the Abstract** are reflected in this paper.

**Amendments to the Claims** are reflected in the listing of claims.

**Remarks** begin after the listing of the claims.